

Electronic Patent Application Fee Transmittal

Application Number:	09605293			
Filing Date:	28-Jun-2000			
Title of Invention:	METHOD FOR CONTROLLING THE MORPHOLOGY OF DEPOSITED SILICON ON A SILICON DIOXIDE SUBSTRATE AND SEMICONDUCTOR DEVICES INCORPORATING SUCH DEPOSITED SILICON			
First Named Inventor/Applicant Name:	DAVID L. CHAPEK			
Filer:	Susan M. Luna/Theresa Oldfield			
Attorney Docket Number:	MIO 0037 VA			
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Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Notice of appeal	1401	1	540	540
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Total in USD (\$)				540